

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: Not yet assigned

Examiner: Not yet assigned

Serial No.: Not yet assigned

Filed: November 25, 2003

In re Application of: WERNER, et al

For: "A SEMICONDUCTOR STRUCTURE FOR USE IN THE NEAR INFRARED REGION AND A METHOD OF MANUFACTURING THIS SEMICONDUCTOR STRUCTURE"

22154 U.S. PTO  
10/723285



Certificate of Express Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as Express Mailing Label No. EV 221306675 US, in an envelope addressed to Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 11/25/03. Signed Tamara Charland

TRANSMITTAL LETTER

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450



Sir:

Enclosed for filing please find the patent application for an invention entitled, "A

SEMICONDUCTOR STRUCTURE FOR USE IN THE NEAR INFRARED REGION

AND A METHOD OF MANUFACTURING THIS SEMICONDUCTOR

STRUCTURE", filed on behalf of Max-Planck-Gesellschaft zur Forderung der Wissenschaften

e. V., a small entity, assignee from inventors Peter Werner, a citizen of Germany, Viatcheslav

Egorov, a citizen of Russia, Vadim Talalaev, a citizen of Russia, George Cirlin, a citizen of

Russia and Nikolai Zakharov a citizen of Russia, including 17 pages of specification, 4 pages of

claims, 1 page of abstract, and 10 sheets of drawing figures.